## NIS COLLOQUIUM ITACA

Ion-beam Techniques Applied to Cultural heritage and Advanced materials







## **Damiano Giubertoni**

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Dr. Damiano Giubertoni is a researcher of the MNF group. His work has been focused on surface characterization, mostly by secondary ion mass spectrometry (SIMS), doping technologies in semiconductors, ion beam induced nanostructures and self-assembly phenomena, nanofabrication by electron beam lithography and focused ion beam techniques. He has co-authored around 100 papers on peer-reviewed journals, hold a patent and he has been tutor for several PhD and M.S. students. Since 2018 he has been following the foundation and management of the

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